APPLICATION DATA SHEET

Electronic Version v14

Stylesheet Version v14.0

Title of Invention

METHOD OF FABRICATING POLYSILICON FILM BY EXCIMER LASER

CRYSTALLIZATION PROCESS

Application Type: regular, utility ADTP0067USA Attorney Docket Number:

Correspondence address:

Customer Number: 027765

Priority Data:

Doc.No: 092112077; Country -TW; Date: 2003-05-02 us-priority-claimed

Inventor Information:

Inventor 1:

Applicant Authority Type: Inventor TW Citizenship:

Kun-chih Given Name:

Family Name: Lin

Residence:

City of Residence: Hsin-Chu Hsien

Country of Residence: TW

Address-1 of Mailing Address: 6F, No. 5, Lane 378, Sec. 2, Chung-Hsing Rd.,

Address-2 of Mailing Address: Chu-Tung Town Hsin-Chu Hsien City of Mailing Address:

State of Mailing Address:

Postal Code of Mailing Address:

Country of Mailing Address: TW

Phone: Fax: E-mail:

Attorney Information:

practitioner(s) at Customer Number:

027765



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